

# Material Issues in Thermal Management of RF Power Electronics

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- System Level
  - Description of system(s)
  - Thermal management issues
    - Temperature gradients
    - Absolute temperature levels
    - Special array-level (AESAs) problems
  - Role of materials at the system level
- Component Level
  - Primary source of thermal dissipation
  - Unique thermal analysis aspects of RF components
  - Role of materials at the component level

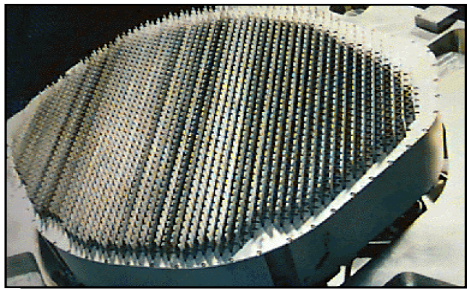
# Phased Array System Hierarchy

| <b>Phased array hierarchy</b> | <b>Physical dimensions, characteristics</b> | <b>Material issues</b>                   | <b>Thermal management issues</b>   |
|-------------------------------|---|--|------------------------------------|
| Active antenna                | Meters, many elements                       | Structural support<br>Thermal gradient   | Coolant routing<br>Heat absorption |
| Slat, Subpanel                | Meter<br>several elements                   | Interconnect,<br>CTE, thermal            | Packaging density                  |
| RF Module                     | Collection of<br>MMICs and ICs              | Dielectric,<br>CTE, thermal,<br>hermetic | Module attach<br>thermal interface |
| Device                        | Power Amplifiers sub-micron active area     | Semiconductor<br>Thermal interfaces      | Die attach<br>FET layout           |

# Typical RF Platforms / Systems

## *Airborne and Ground Systems*

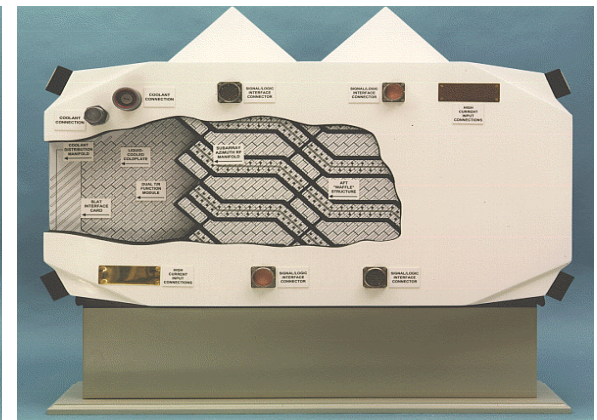
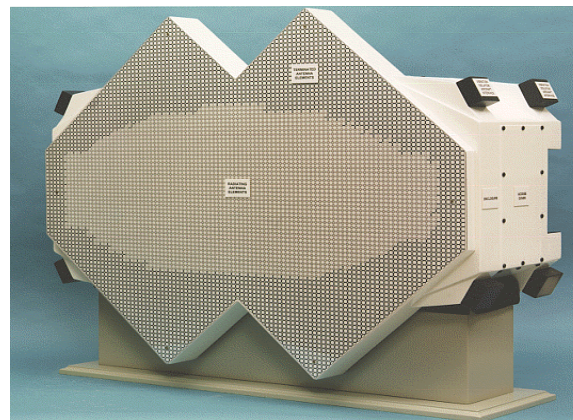
- Often require designs for continuous operation



Airborne



Ground based

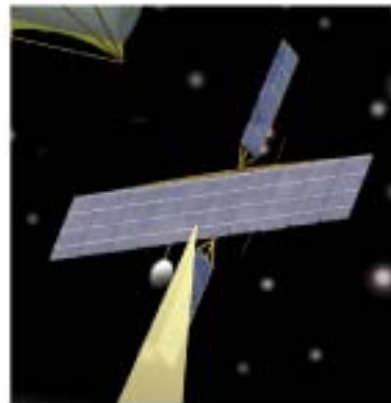
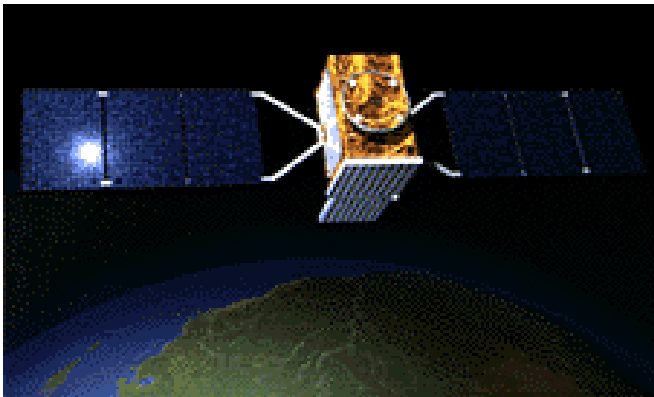


Shipborne

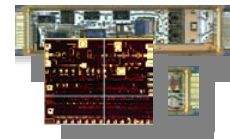
# Typical RF Platforms / Systems

## *Satellite Systems*

- Large antenna dimensions
- May have thousands of modules
- May have option of intermittent or short term operation



**Modules**



**MMICs**



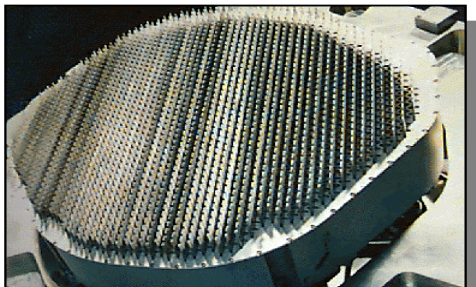
**Power Converter**



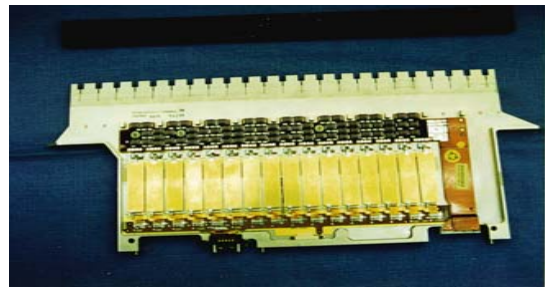
# Typical RF Platforms / Systems

## Phased-Array Radars

- Phased-array radars typically operate at frequencies from 1 to 30 GHz and dissipate from hundreds to tens of thousands of KW of waste heat
- Phased-array radars often contain many thousands of microwave modules as building blocks for AESA (**Active Electronically Steered Arrays**)
- Power dissipations of ground-based systems are typically higher than airborne systems because of physical size, but dissipation flux levels are comparable

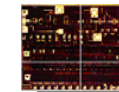
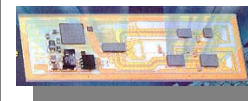


Active Array



Subarray (Slat)

Modules



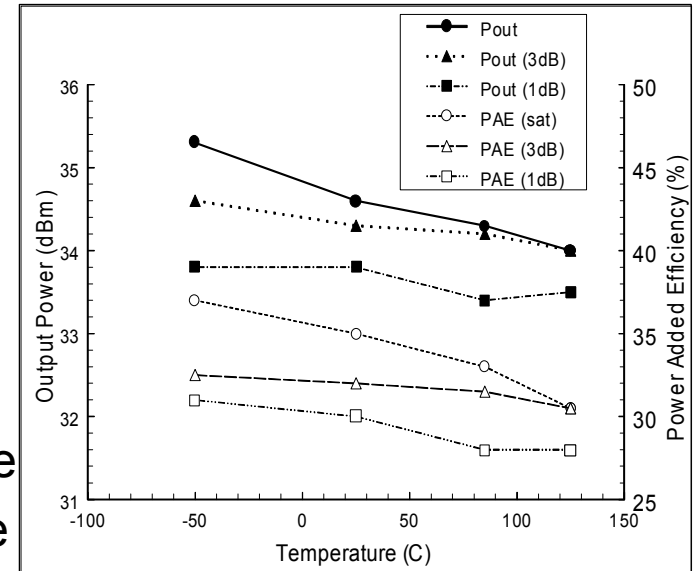
MMICs



Power Converter

# Critical Thermal Management Issues Related to Cold Plate Design

- Temperature Issues
  - Absolute temperature
    - Reliability
    - Electrical performance
    - Failure temperature limit
  - Temperature gradients
    - RF phase shift is temperature dependent
    - Higher operating frequencies are more demanding
    - Gradients need to be constant over operating frequency range from a calibration standpoint



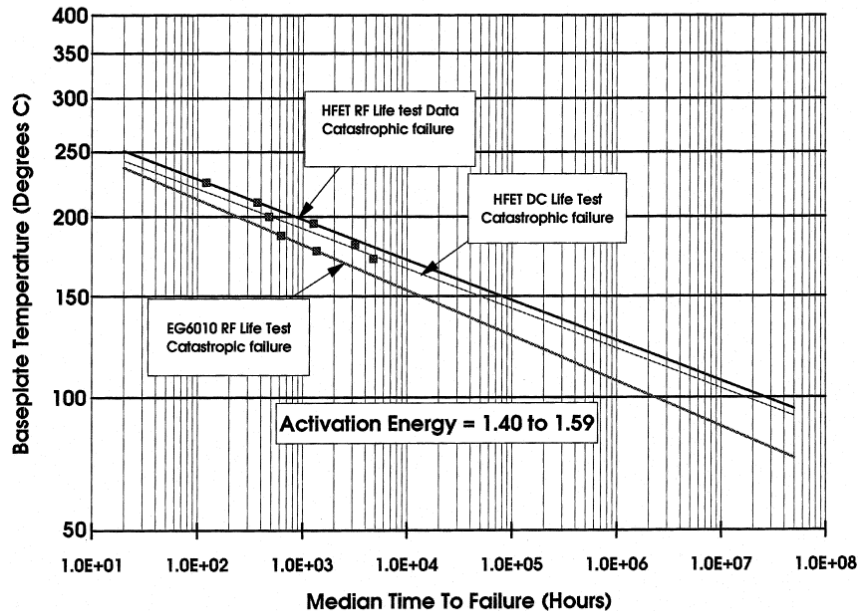
| Operating Frequency<br>of Phased-Array | Maximum Allowable<br>Temperature Difference<br>Across Array |
|--|---|
| (GHz)                                  | (°C)  |
| 5                                      | 20  |
| 10                                     | 10  |
| 20                                     | 5   |
| 40                                     | 2.5   |
| 80                                     | 1.3   |



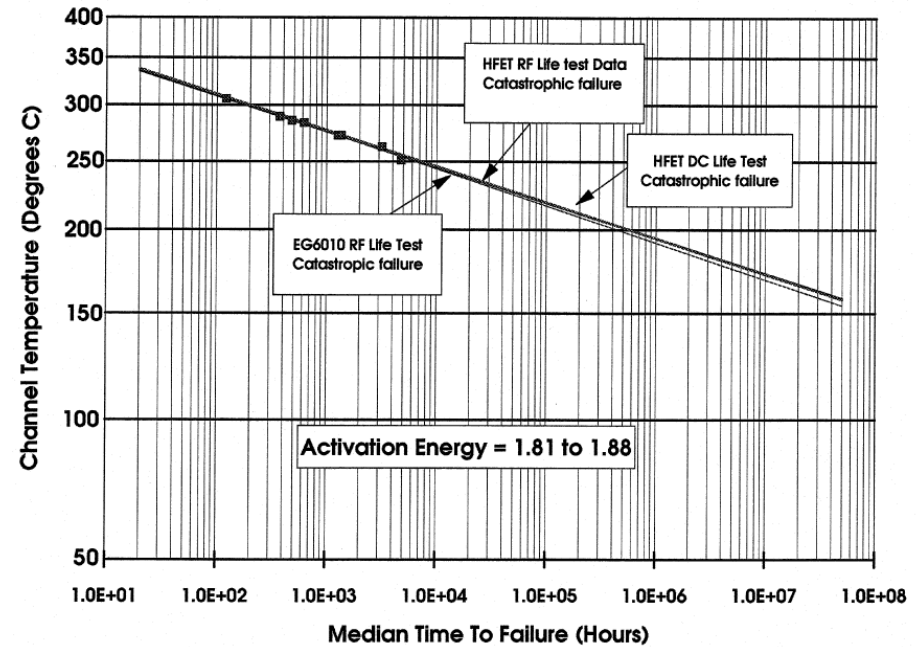
# Reliability Issue

## *Requires Use of Channel Temperature*

ARRHENIUS PLOT



ARRHENIUS PLOT



Same data plotted considering either base or channel temperature

# Role of Materials

## *System Level*

- System usually employs cold plate structures which become the heat sink for the dissipating electronics
- Cold plate cooling methods
  - Forced fluid
  - Phase change material (both cyclical and expendable)
  - Heat pipes and capillary pump loops
- Thermal conductivity enhancements for cold plates in use
  - High conductivity graphite (TPG) for lateral conduction
  - Convection enhancement with compact finstock and aluminum foams
  - Phase change material conductivity enhancement with high thermal conductivity graphite foam (satellite and missile applications)

# Role of Materials

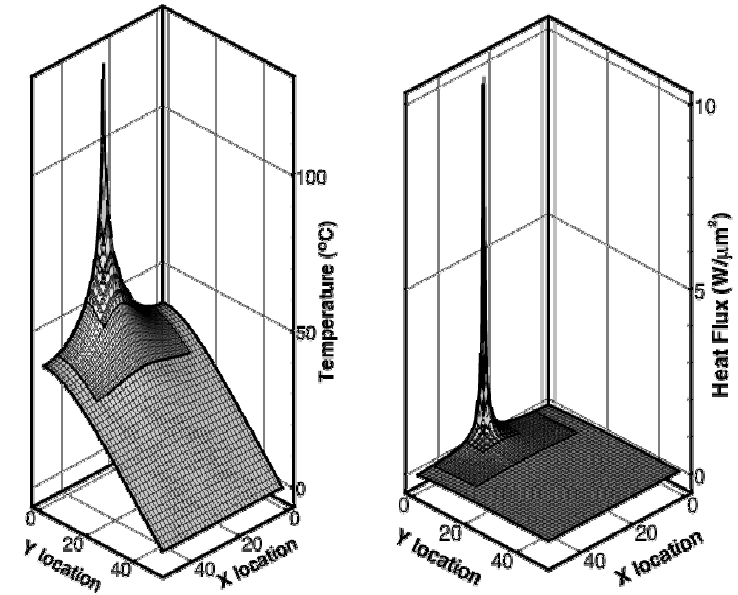
## *System Level (continued)*

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- Wide environmental operating range requires that coefficient of thermal expansion (CTE) differences be addressed
  - RF electronic package materials are set and not likely to change
  - Constrain the cold plates
    - Aluminum Silicon Carbide cold plates provide good match
  - Compliant bonds
    - Thermal concerns (this is often the weak link in the thermal design)
    - Good for repairability concerns
- Material compatibility (from the standpoint of galvanic corrosion) must also be considered
  - Long shelf life required
  - Usually solved by metal plating

# Power Dissipation and Heat Flux Issues

|                                   | Typical<br>Dissipation<br>(Watts) | Typical Heat<br>Flux<br>(W/cm <sup>2</sup> ) |
|-----------------------------------|-----------------------------------|--|
| FET                               | 1 to 15                           | Order of 1E7 at<br>junction                  |
| MMIC<br>Several FETs              | 1 to 20                           | 100 - 2000<br>(at base MMIC)                 |
| Module<br>(several<br>MMICs)      | 1 to 50                           | 1 to 5                                       |
| Coldplate<br>(several<br>modules) | 10 to 2000                        | 0.5 to 3                                     |
| System<br>(several<br>coldplates) | 100 to many kW                    | Order of 1                                   |



Concentrated heat flux  
at device junction

# Outline

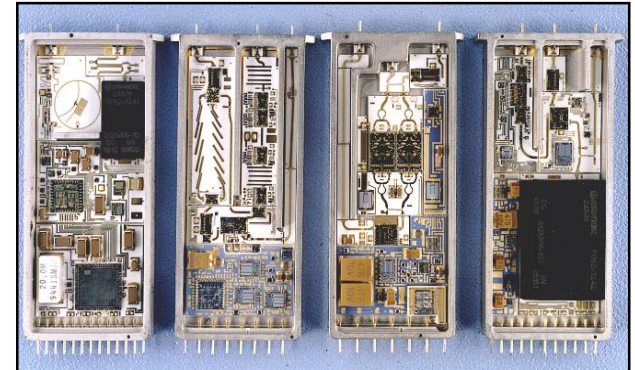
## *TR Module and MMIC Thermal Issues*

- TR Module and MMICs
  - Description
    - Materials
  - Analysis
    - Specialized techniques
    - Examples
  - Verification
    - IR imaging

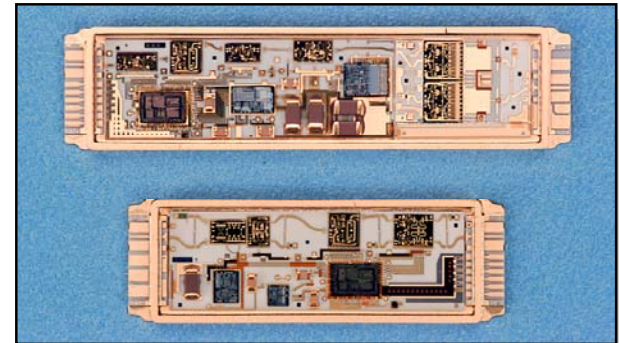
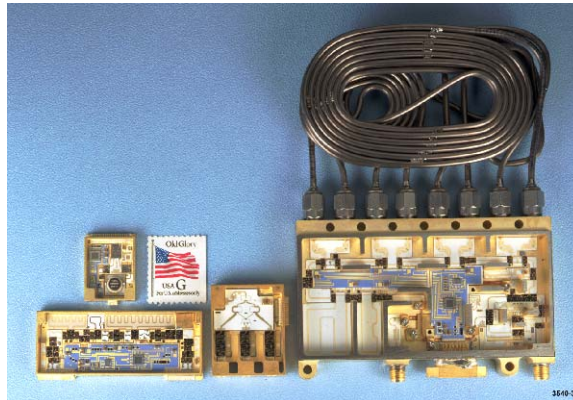
# Illustration of TR Modules

- TR modules are the basic building blocks of phased- array antennas
- Typically a single T/R channel

## Towed Decoy



## Space

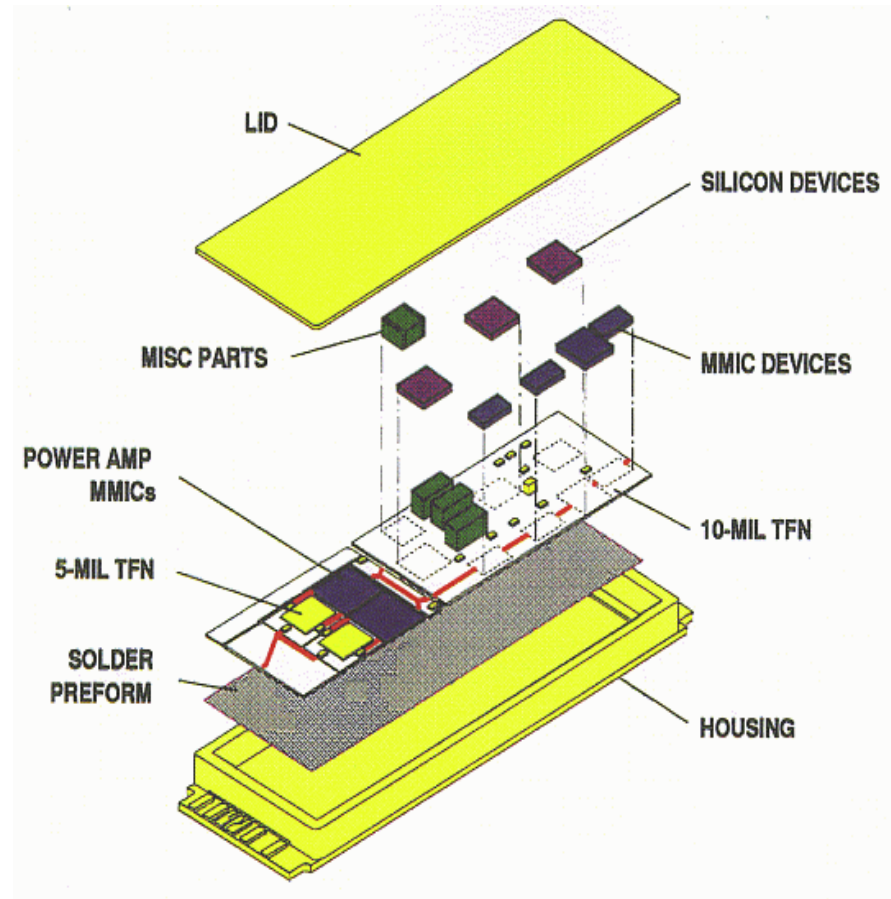


## Airborne Radar



# Packaging of TR Modules

- Typically require hermetic sealing
  - Welded and brazed connections
- Built-in layers
  - Thermal interfaces are important for power devices
  - Require CTE matched materials



# Role of Materials

## *Package Level*

---

- Dielectric substrates
  - $\text{Al}_2\text{O}_3$ , BeO, AlN, thick film, some circuit board
- Heat spreaders for MMICs/Module base
  - Copper Moly, Copper Tungsten, Diamond, Molybdenum, Kovar, Titanium
- Die attach
  - Solders (AuSn, SnPb, Indium)
  - Silver-filled epoxy
  - Z-axis material and solders for flip chip
- Module attach
  - Compliant adhesives, filled epoxies, metal-metal
  - Ball grid array

# Module/MMIC Thermal Analysis

## *Requirements for Numerical Solution*

---

- Numerically difficult
  - Large scale range
  - Non-linear material properties (GaAs, GaN, SiC, BeO)
  - Fully three-dimensional
  - Pulsed operation (transient analysis required)
- Often a majority of the total temperature rise from the junction to sink is in the module and MMIC
  - Thermal design of module/MMIC most important from an ambient-to-junction temperature rise perspective

# Transition From System To Device

## Antenna Level

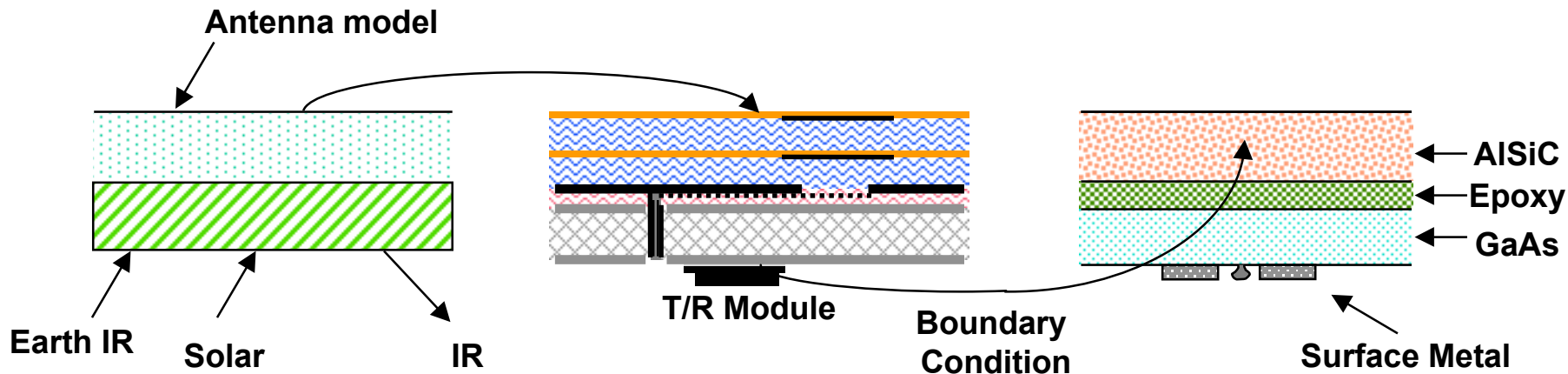
- Orbit environment or system level analysis
- Provide boundary condition for module model
- Time scale in minutes

## Module Level

- Boundary condition from antenna model
- Predict module base temperature for operating conditions
- Time scale in seconds

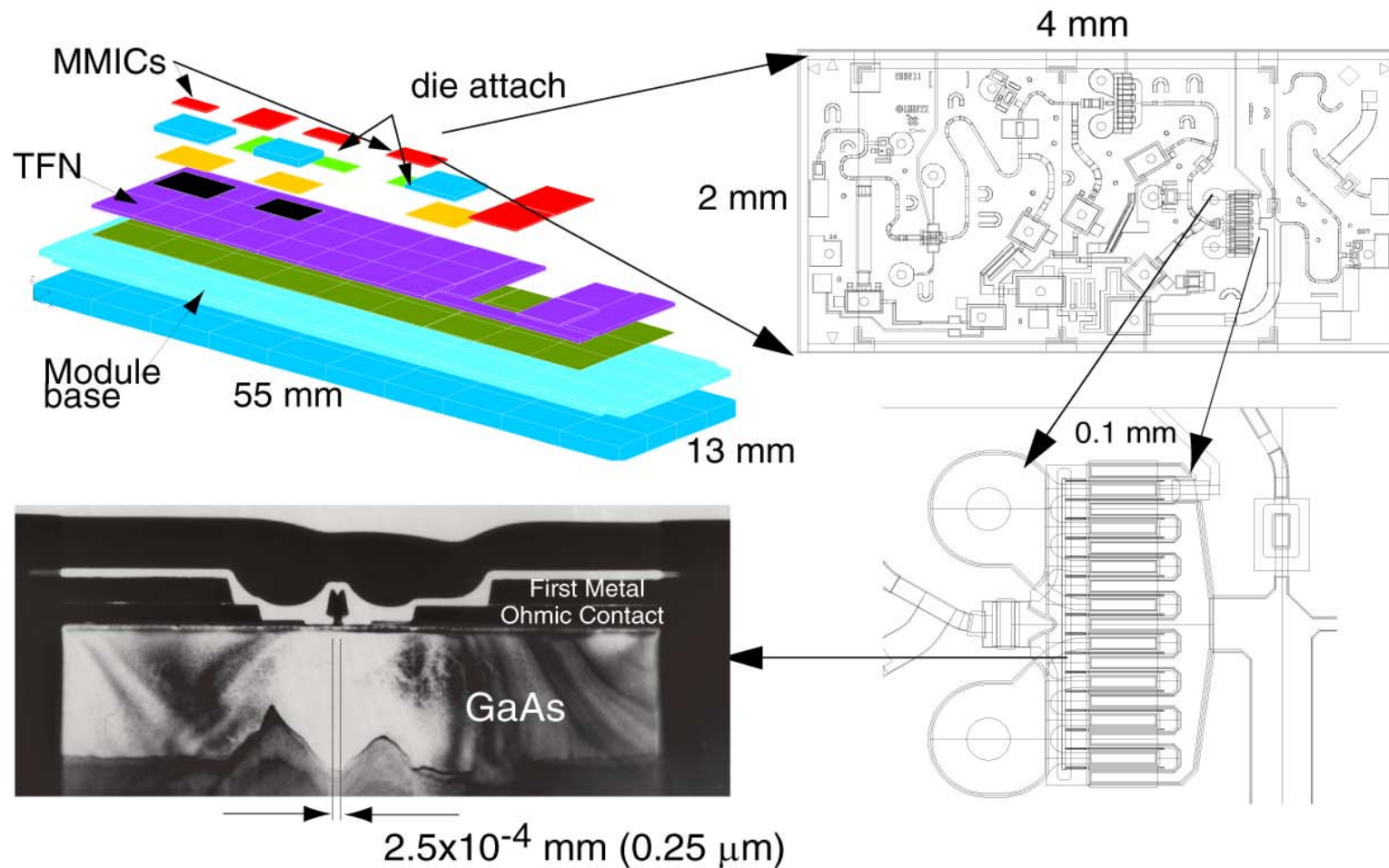
## MMIC Level

- Boundary condition from module model
- Junction temperature prediction
- Time scale in microseconds



# Scale Variation

## *MMICs and Microwave Modules*



5 to 7 orders of magnitude variation in both space and time scales

# Power Amplifiers

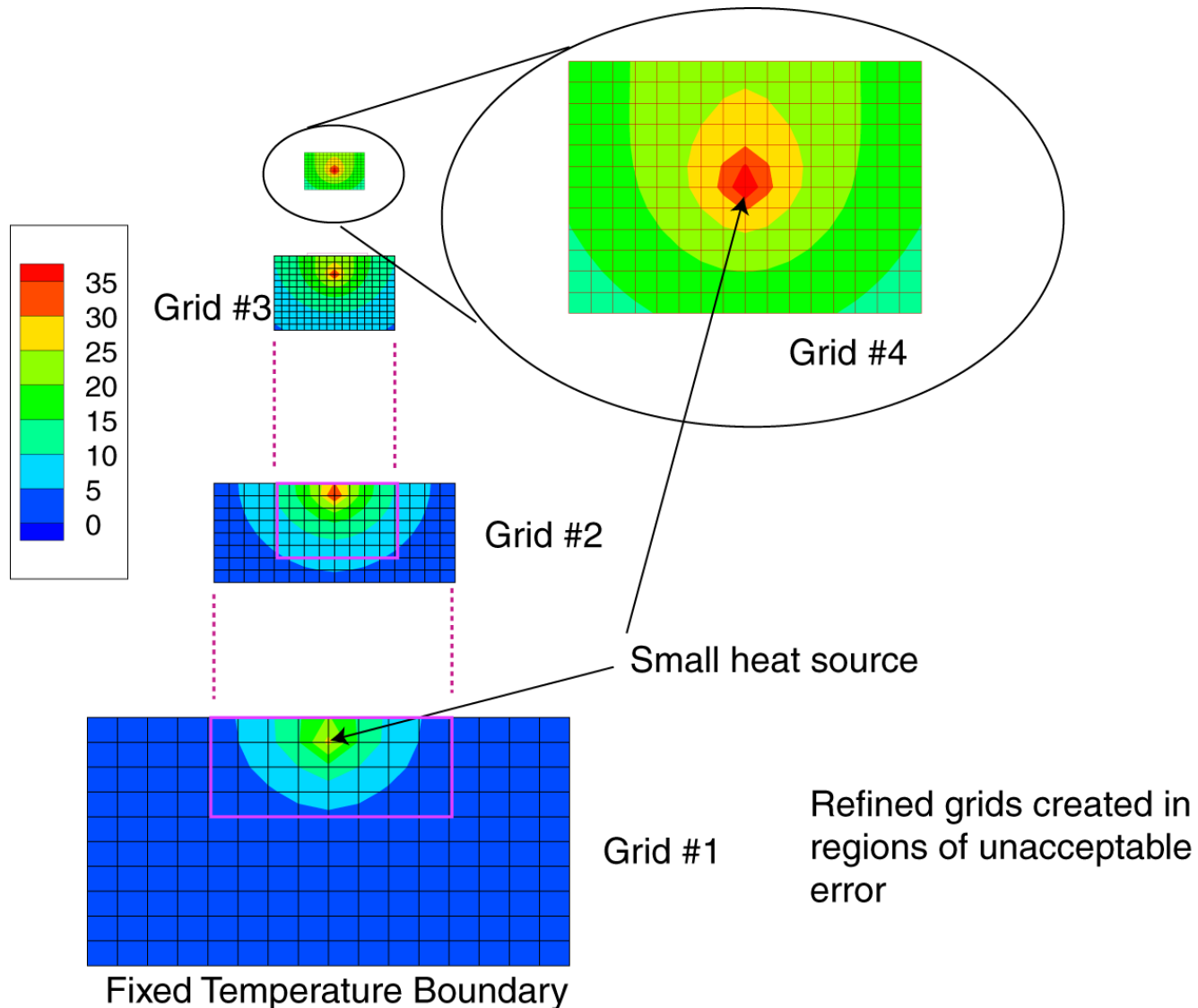
## *Often Critical Component*

- RF Power Amplifiers
  - GaAs dissipation on the order of 1 W/mm
  - GaN currently at 5 W/mm, soon to be near 9 W/mm with process improvements
  - GaAs heat flux on the order of 1000 W/cm<sup>2</sup> at base of amplifier (several thousand for GaN/SiC)
  - Often operated in a pulsed mode
    - Duty-cycle (time-average) power will usually apply below MMIC base (assuming pulse width less than 1 msec)

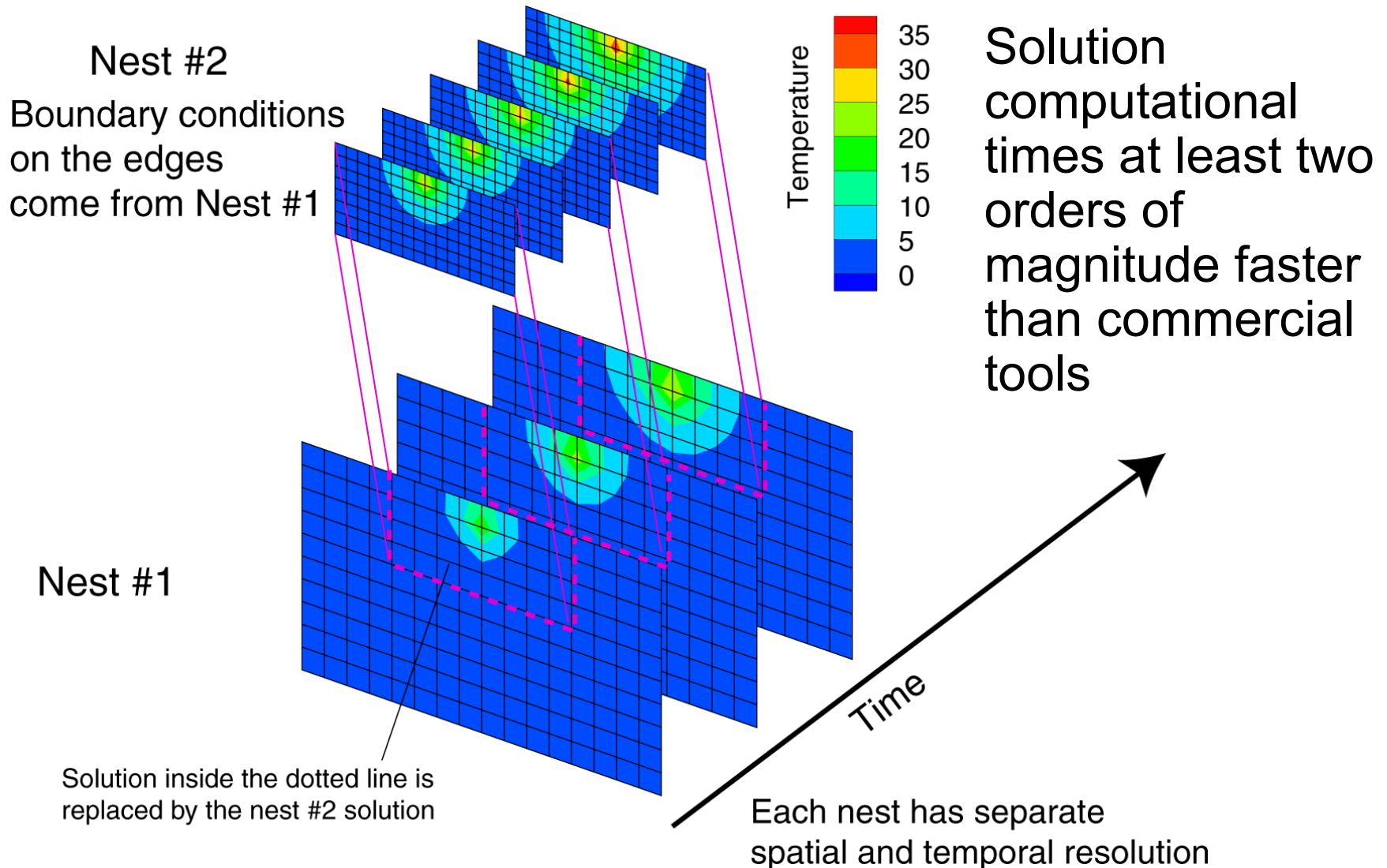


- Large scale range(s) require specialized approach for solving FET/MMIC time dependent thermal problems
  - Finite Difference Approximations
  - Uniform Grid Spacing
  - Control Volume Formulation
    - Effective thermal properties smeared across multiple materials
    - Arbitrary alignment between grid and physical geometry
  - Successive Refinement in space and time
    - Like graphics information transfer on internet

# Steady-State Nesting

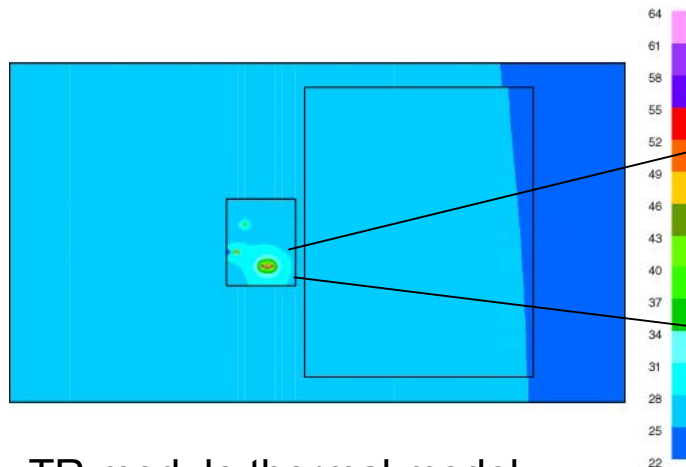
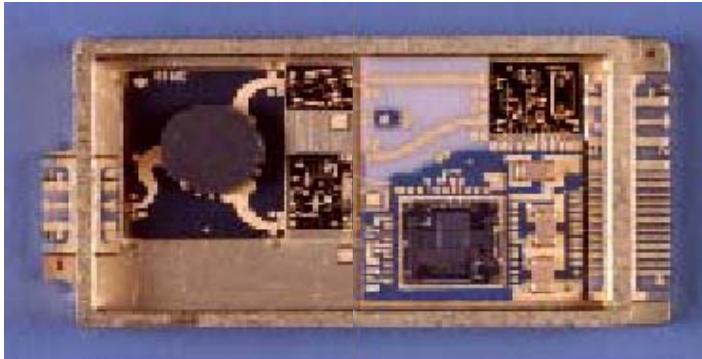


# Transient Nesting

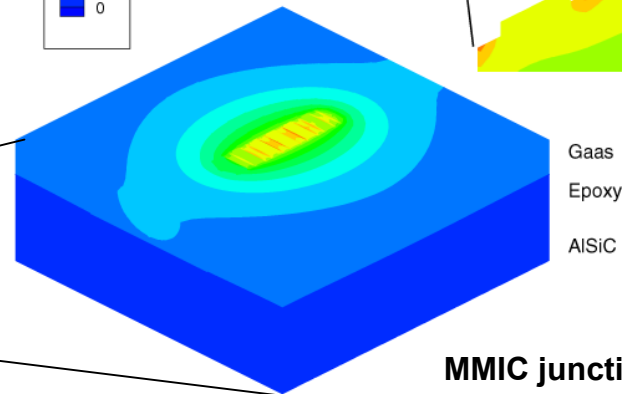
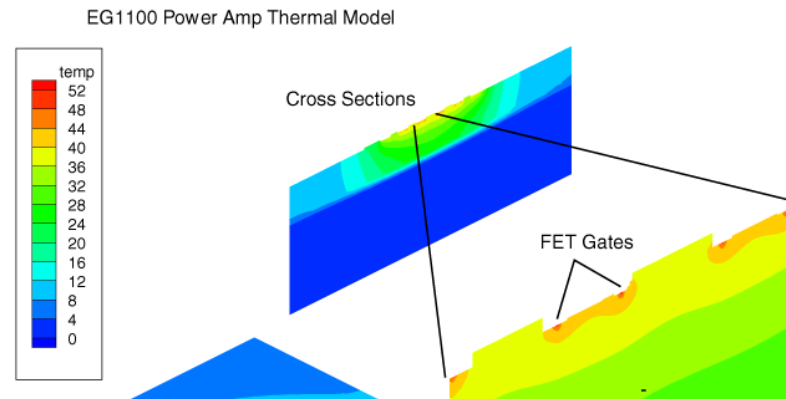


# Example TR Module/MMIC Model Results

Significant portion of the rise in the GaAs  
Future module packaging techniques (flip  
chip, BGA) still are on the order of 60 C rise



TR module thermal model

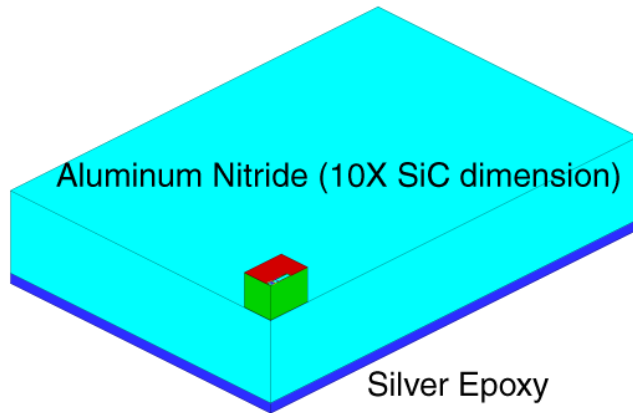


MMIC junction is 54 C  
above the module mounting  
surface (module rise is 4C)

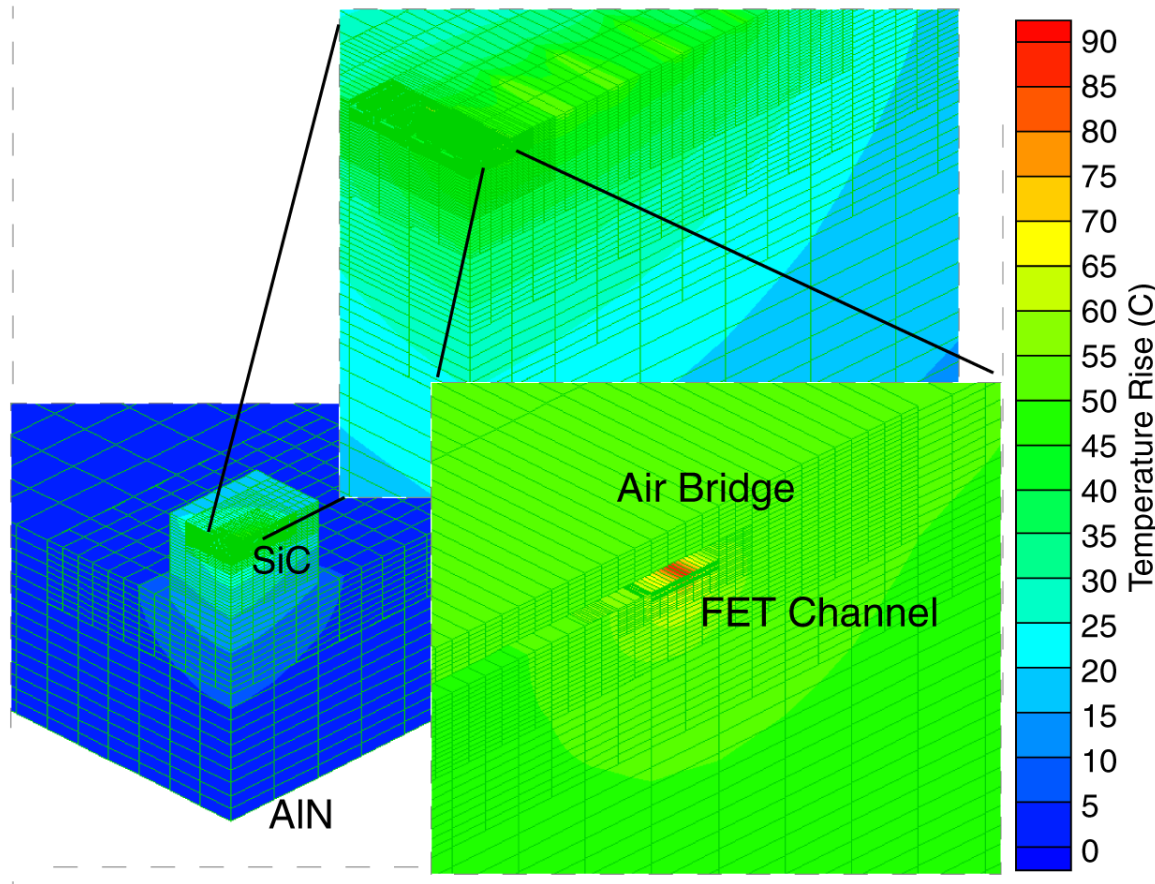
50 C rise from AlSiC pedestal to junction (with CW power dissipation)

# Thermal Model of GaN FET

## *1/4 Section Adaptive Mesh*



- **thermosonic die attach (5  $\mu\text{m}$  Au)**
- **4.5 W/mm dissipation**
- **50  $\mu\text{m}$  gate-gate**
- **10 fingers**  
**@125  $\mu\text{m}$  length**

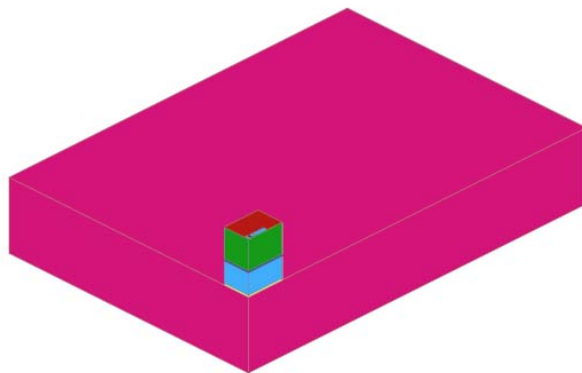


# Package Materials /Trades

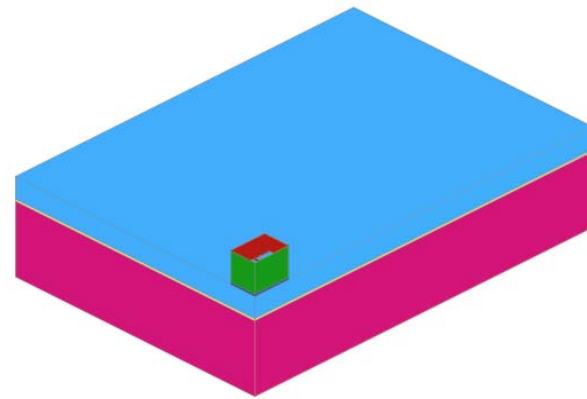
## *Diamond Heat Spreader*

Evaluations at 4.5 W/mm dissipation

|                | SiC Thk (microns) | Diamond area | Temperature Rise (C) | Comparison case to one AuSn layer and same SiC thickness - no diamond |
|----------------|-------------------|--------------|----------------------|---|
| Thick Discrete | 425               | same as SiC  | 91.4                 | 89.3  |
| Thin Discrete  | 125               | same as SiC  | 84.3                 | 85.0  |
| Thick MMIC     | 425               | same as AlN  | 80.0                 | 89.3  |
| Thin MMIC      | 125               | same as AlN  | 72.9                 | 85.0  |



Diamond heat spreader same size as SiC



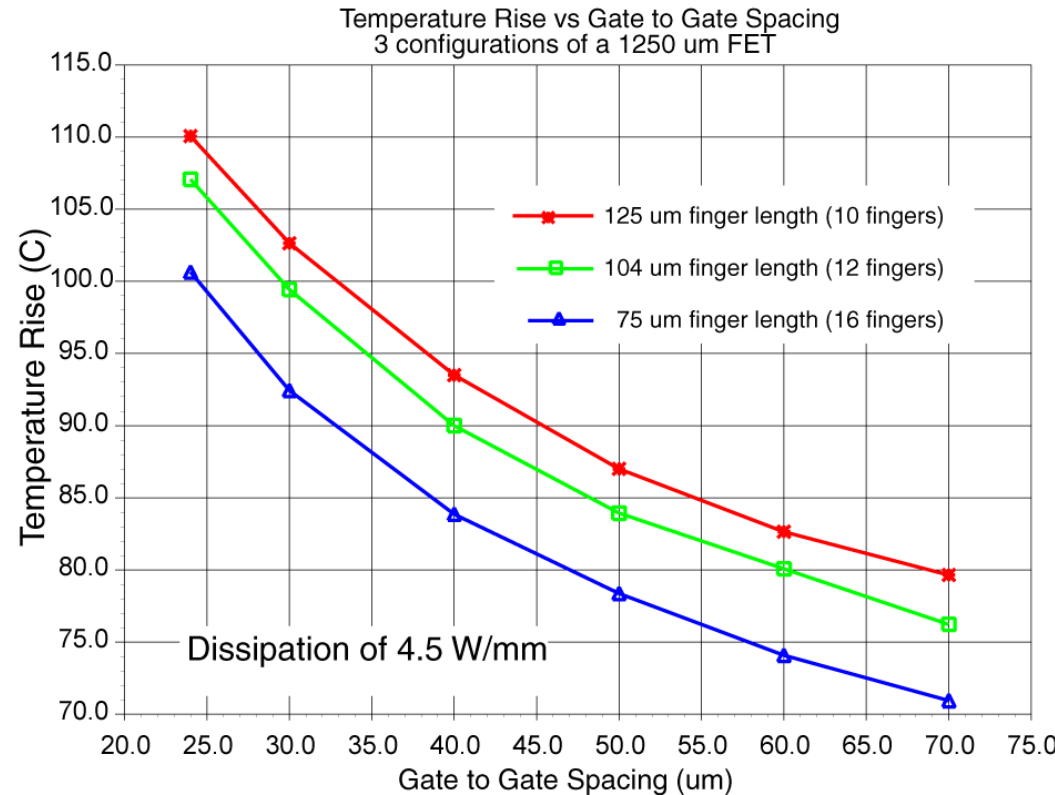
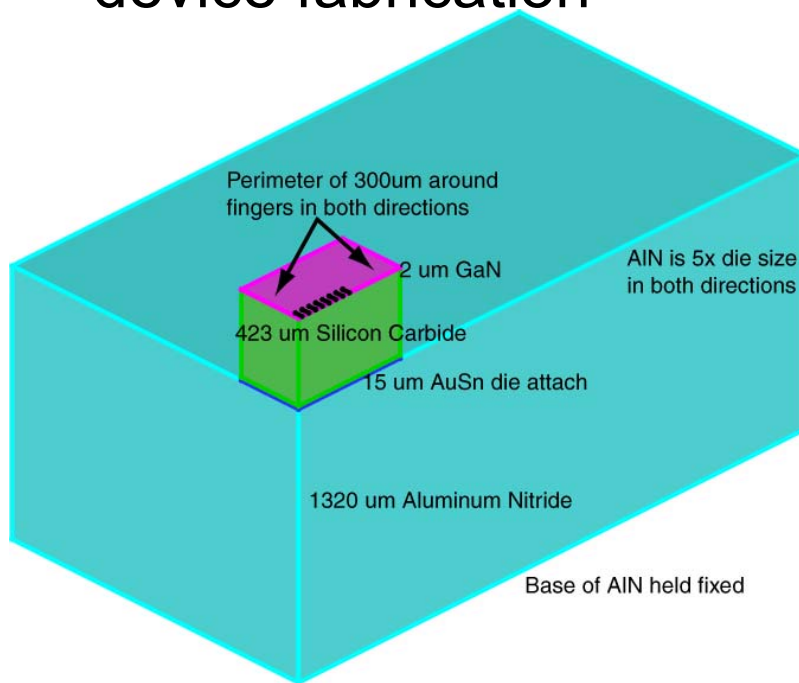
Diamond heat spreader same size as AlN

**Benefit with diamond for MMICs but not for discrete FETs**

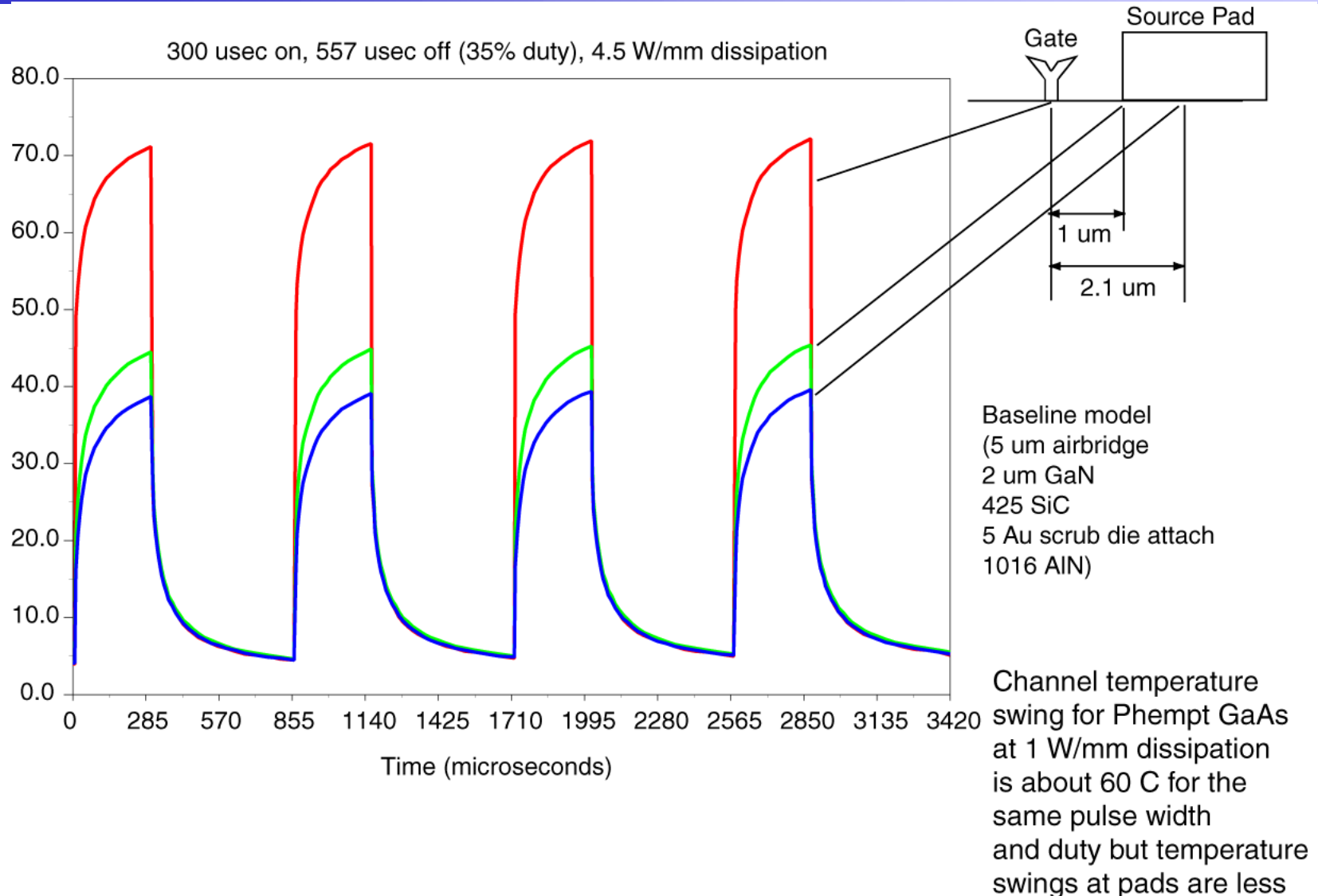


# GaN FET Channel Spacing Trade

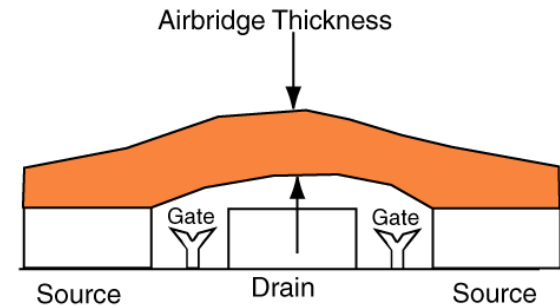
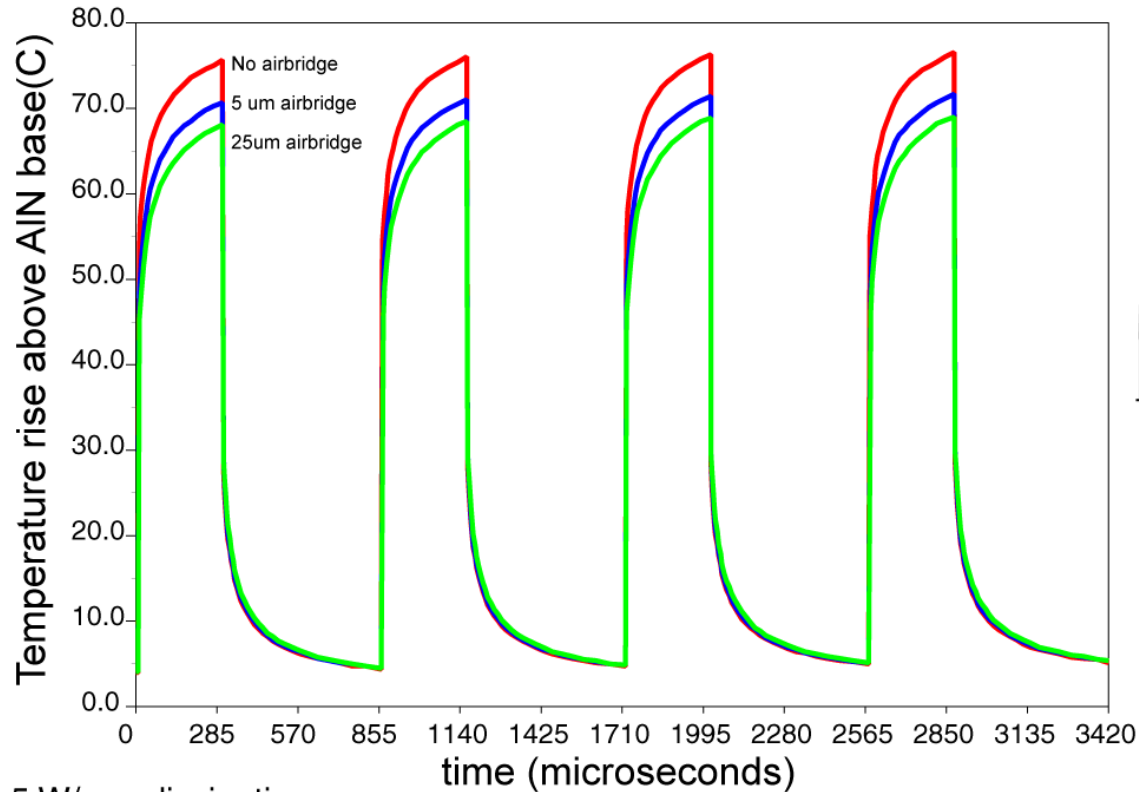
Rapid thermal analysis capability allows design trades prior to device fabrication



# Transient Analysis at Pads



# Transient Analysis

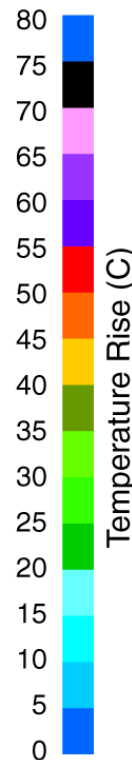
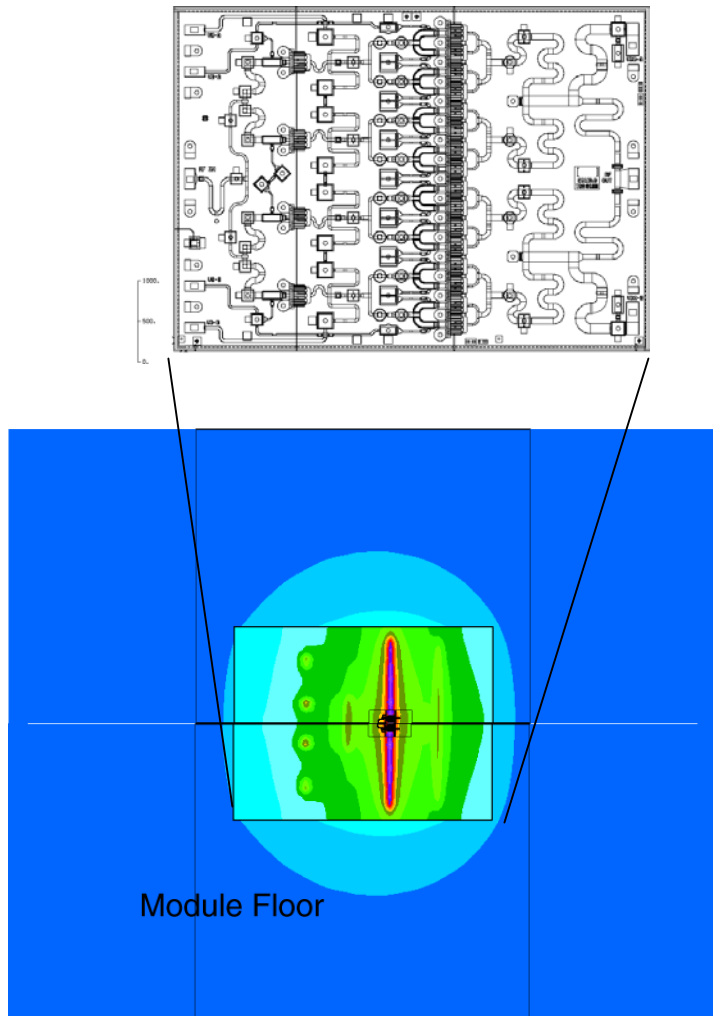


4.5 W/mm dissipation  
base of AlN held fixed  
SiC conductivity = 272 W/m-K  
10 finger FET, 50 um g-g

On for 300 usec, off for 557 usec

2 um GaN  
423 um SiC  
5 um Au  
1016 AlN

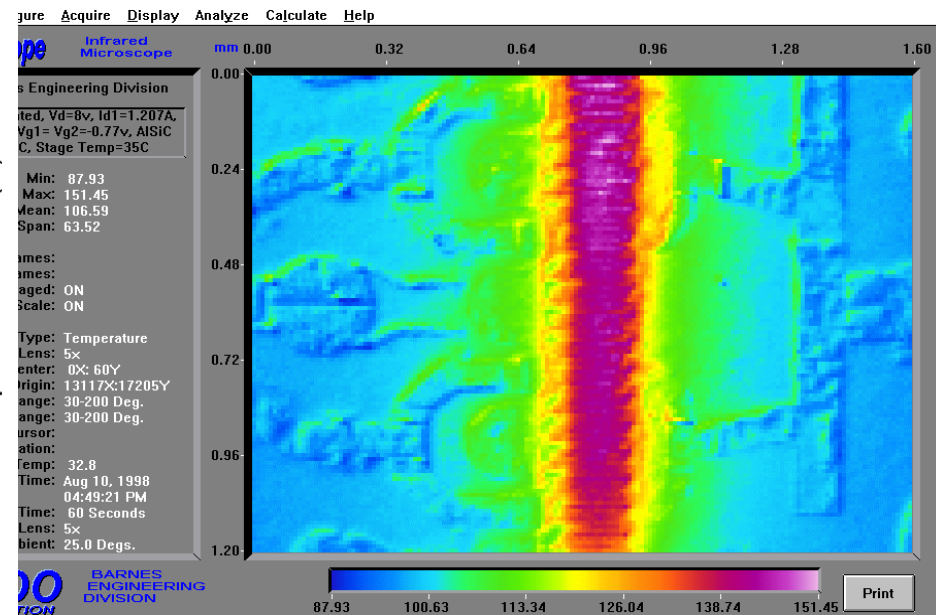
# Model Verification with IR



IR at 10  $\mu\text{m}$  resolution

Test: 106 C rise

Model: 102 C rise



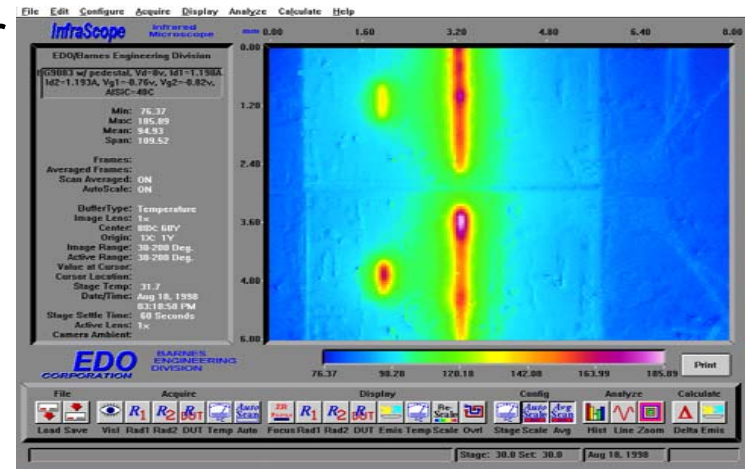
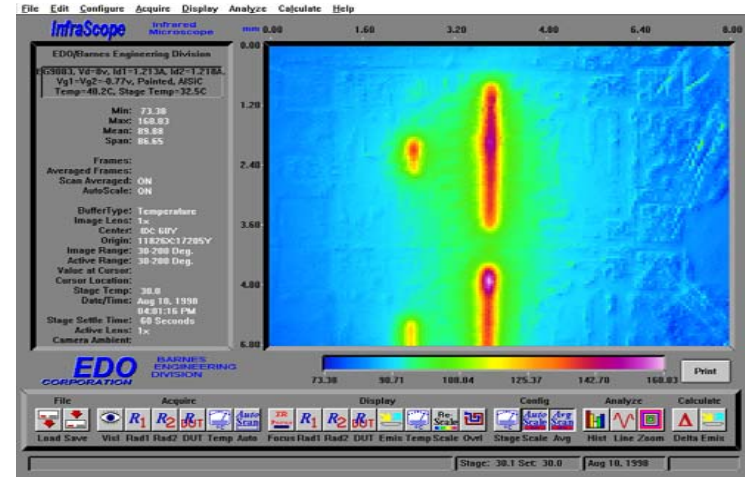
# Thermal Interface for Die Attach

Repair and rework concerns favor the use of silver-filled epoxy to attach power amplifiers to module floors - (power amplifier is soldered to a heat spreader which is then attached with epoxy)

Direct Attach

Comparison of direct attach and spreader mounted power amps. Same DC power for both cases, IR images indicate about a 15 - 20 C junction temperature increase for the pedestal mounted part

Heat spreader (10 mil CM15 plus 1 mil epoxy)



- Material interface issues very important
  - Module and die attach (heat flux high)
  - Compliant attach may be required because of CTE concerns
- Thermal analysis needs to be integrated into the power amplifier design process
- Material properties for “thin film” materials at device level are not well known (surface metalization)